



Attorney Docket No.: 0756-1998

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#15/B
DEPT/AS
2/13/01

In re Patent Application of
Shunpei YAMAZAKI et al.

Art Unit: 2823

Serial No.: 09/352,194

Examiner: F. Toledo

Filed: July 13, 1999

CERTIFICATE OF MAILING

For: CRYSTALLINE SEMICONDUCTOR
THIN FILM, METHOD OF
FABRICATING THE SAME,
SEMICONDUCTOR DEVICE, AND
METHOD OF FABRICATING THE
SAME

I hereby certify that this
correspondence is being deposited with
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Commissioner for Patents, Washington,
D.C. 20231, on 1-29-01

J. Andrew McCallister

AMENDMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 28, 2000, the period for reply extended
by the attached Petition for Extension of Time, please amend the above-identified application as
follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Page 13, line 16, after "as the under film" insert --102--.

Page 22, line 23, please change "804" to --1204--.

Page 28, line 17, please change "Hbr" to --HBr--.

Page 33, line 1, please change "group 13" to --group IIIA--;

line 14, please change "405" to --402--.

Page 35, line 7, please change "408" to --508--.

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